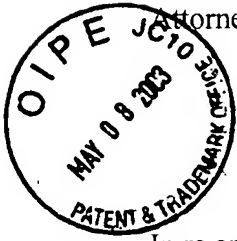


Form PTO-1449

Attorney Docket: GD7376US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE CITATION

In re application of: Jiangtao Wang et al.

Serial No: 10/074,988

Group No.: 2824

Filed: February 13, 2002

Examiner: Michael Lebentritt

For: PROCESS FOR MANUFACTURING COPPER
FOIL ON A METAL CARRIER SUBSTRATE

Commissioner for Patents
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U.S. Patent Documents

Examiner Initials	Document Number	Date	Name	Class
<u>DM</u>	4,737,446	04/12/1988	Cohen et al.	430/311
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Other Prior Art (Inc. Author, Title, Date, Pertinent Pages, Etc.)

Examiner

Initials

Document

DM

U.S. Patent Application Publication No. 2001/0019780, publication date, September 6, 2001, Obata et al., entitled: METAL FOIL WITH CARRIER AND METHOD FOR MANUFACTURING THE SAME.

DM

U.S. Patent Application Publication No. 2003/0029730, publication date, February 13, 2003, Lee et al., entitled: COPPER ON INVAR[00ab] COMPOSITE.

Examiner:

Dong Myung

Date Considered:

8/6/03

**Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

Form PTO-1449

Attorney Docket: GD736US



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE CITATION

In re application of: Jiangtao Wang et al.

Serial No: 10/074,988

Group No.: 2812

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Examiner: Unknown

For: PROCESS FOR MANUFACTURING COPPER FOIL ON
A METAL CARRIER SUBSTRATE

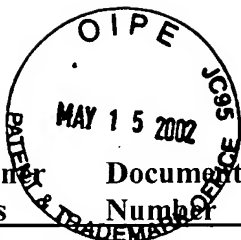
Assistant Commissioner for Patents

Washington, DC 20231

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Examiner Initials	Document Number	Country	Class	Translation (Yes/No)
<u>MM</u>	EP0872301	Europe	B23K20/10	Yes

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Examiner:

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